

In re the Application of: FUKASAWA, Shinji

Group Art Unit: 2814

28/4/A

Serial No.: 09/855,590

Examiner: T. N. QUACH

Filed: May 15, 2001

P.T.O. Confirmation No.: 1417

For.

SEMICONDUCTOR DEVICE HAVING A MULTIPLE LAYER WIRING STRUCTURE, WIRING METHOD, WIRING DEVICE, AND RECORDING

MEDIUM

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: December 10, 2004

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated August 10, 2004 for one month, from November 10, 2004 to December 10, 2004.

Attached please find a check in the amount of \$120.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP

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120.00 OP

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